

**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

|   |                                   |
|---|-----------------------------------|
| In re the Application of:   | Confirmation No.: 5377            |
| Makiko KITAZOE, et al   | Art Unit: 1792                    |
| Application No.: 10/591,905   | Examiner: Keath T. CHEN           |
| Filed: November 6, 2006   | Attorney Docket No.: 029567-00010 |
| For: SELF-CLEANING CATALYTIC CHEMICAL VAPOR DEPOSITION APPARATUS<br>AND CLEANING METHOD THEREOF |                                   |

**AMENDMENT UNDER 37 C.F.R. §1.116**

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 20, 2008

Sir:

In reply to the June 19, 2008, Office Action, the period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, being on page 2;  
and

Remarks begin on page 7.